CLAIMS:

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| What is claimed i | c. |
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- 3 1. A method of manufacturing an electronic-charge-transferring device comprising:
- 4 providing a charged species source and a charge species drain; and
- 5 manufacturing a moveable component for transferring charge to the
- 6 charged species drain, a first protrusion proximate to the moveable component,
- and a second protrusion proximate to the moveable component, wherein the
- 8 moveable component is positioned in close proximity to the charged species
- 9 source, and wherein at least one of the moveable component, the first protrusion
- and the second protrusion is micro-manufactured.
- 11 2. The method of claim 1, wherein the providing step comprises providing a micro-
- manufactured charged species source.
- 13 3. The method of claim 1, wherein the providing step comprises providing a micro-
- manufactured charged species drain.
- 15 4. The method of claim 1, wherein the providing step comprises providing the
- charged species source and the charged species drain in contact with the moveable
- 17 component.
- 18 5. The method of claim 1, wherein the manufacturing step comprises including a
- first material in the first protrusion and a second material, different from the first
- 20 material, in the second protrusion.
- 21 6. The method of claim 5, wherein the manufacturing step comprises including a
- 22 third material, different from the first material and the second material, in the
- 23 moveable component.
- 24 7. The method of claim 1, further comprising positioning the first protrusion and the
- second protrusion in contact with the moveable component.
- 26 8. The method of claim 1, further comprising electrically connecting a device to the
- charged species drain.
- 28 9. A method of transferring electric charge comprising:
- 29 providing a first charged species source and a first charged species drain;
- 30 micro-manufacturing at least one of a first moveable component, a first
- protrusion, and a second protrusion, wherein the moveable component is
- positioned proximate to the first charged species source and the first charged
- species drain, and wherein the first protrusion and the second protrusion each
- contact the first moveable component; and

| 1 | | moving the first moveable component relative to the first charged species |
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| 2 | | source and the first charged species drain. |
| 3 | 10. | The method of claim 9, wherein the providing step comprises micro- |
| 4 | | manufacturing the first charged species source and the first charged species drain. |
| 5 | 11. | The method of claim 9, wherein the moving step comprises translating the first |
| 6 | | moveable component relative to the first charged species source. |
| 7 | 12. | The method of claim 9, wherein the moving step comprises rotating the first |
| 8 | | moveable component about a rotation axis. |
| 9 | 13. | The method of claim 9, further comprising tribocharging the first protrusion and |
| 10 | | the second protrusion. |
| 11 | 14. | The method of claim 9, further comprising using the first charged species drain to |
| 12 | | supply an electric current to a device. |
| 13 | 15. | The method of claim 9, further comprising providing a second moveable |
| 14 | | component, a second charged species source and a second charged species drain, |
| 15 | | each positioned proximate to the second moveable component, and a third |
| 16 | | protrusion and a fourth protrusion, each positioned proximate the second |
| 17 | | moveable component, wherein the first charged species drain and the second |
| 18 | | charged species drain are each electrically connected to a device. |
| 19 | 16. | The method of claim 15, further comprising moving the second moveable |
| 20 | | component out of phase with the first moveable component. |
| 21 | 17. | A van de graaf device comprising: |
| 22 | | a moveable component; |
| 23 | | a charged species source proximate to the moveable component; |
| 24 | | a charged species drain proximate to the moveable component; |
| 25 | | a first protrusion contacting the moveable component; and |
| 26 | | a second protrusion contacting the moveable component, wherein at least |
| 27 | | one of the moveable component, the first protrusion and the second protrusion is |
| 28 | | micro-machined. |
| 29 | 18. | The van de graaf device of claim 17, wherein the charged species source is |

The van de graaf device of claim 17, wherein the charged species source and the

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electrically grounded.

charged species drain are micro-machined.

- 1 20. The van de graaf device of claim 17, wherein the first protrusion comprises a
- 2 material that can be tribocharged by a material comprised in the moveable
- 3 component.